



100-15-9280

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

K. Kata et al.

Serial No.: 08/533,207

Group Art Unit: 2503

Filed: September 25, 1995

Examiner: M. Prenty

For: PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE  
AND SEMICONDUCTOR WAFER

RECEIVED

JUL 16 1997

GROUP 2500

Assistant Commissioner of Patents  
Washington, D.C. 20231

**PETITION AND FEE FOR EXTENSION OF TIME**  
**UNDER 37 C.F.R. 1.136(a)**

Sir:

Applicant hereby petitions for a one-month extension of time to respond to the Office Action mailed February 18, 1997. A check for the extension fee in the amount of \$110.00 is attached. Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 23-1951. An Amendment responsive to the outstanding Office Action is being filed simultaneously herewith.

Respectfully submitted,

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